

Docket No.: IN-1078



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By: M. P.

Date: February 14, 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Matthias Förster et al.
Applic. No. : 09/901,526
Filed : July 9, 2001
Title : Process for Producing a Microroughness on a Surface
Art Unit : 3723

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TC 3700 MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 6,060,354 (Tsu et al.), dated May 9, 2000;

German Published, Non-Prosecuted Patent Application DE 42 06 848 A1 (Tuttle), dated October 15, 1992, method for texturizing poly crystalline silicone;

German Published, Non-Prosecuted Patent Application DE 196 32 834 A1 (Schäfer et al.), dated February 19, 1998, method for producing fine structures.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications,

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patents and/or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,



For Applicants

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Date: February 14, 2002

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